Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/572,625	RAO ET AL.	
Examiner	Art Unit	
Jafar Parsa	1621	

SEARCHED					
Class	Subclass	Date	Examiner		
570	175	2/20/2007	JP		
570	176	2/20/2007	JP		
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH N (INCLUDING SEARC		)
	DATE	EXMR
East	2/20/2007	JP
inventor name search	2/20/2007	jp
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